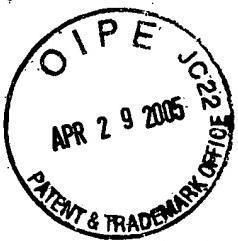


IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : Don Powell et al.  
Serial No. : 10/706,415  
Filed : November 12, 2003  
Title : METHOD OF FABRICATING A SEMICONDUCTOR DEVICE  
Docket No. : MIO 0060 V3 (98-0814.03)  
Art Unit : 2818  
Examiner : Dung A. Le

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 27, 2005.

*Susan M. Fine*

Agent Reg. No. 38,769

AMENDMENT

This paper is being filed in response to the Office Action mailed March 14, 2005. Reconsideration and allowance of the application are respectfully requested in light of the amendments and remarks below.